

2/15/2006 Response to Office Action
U.S.S.N. 10/814,714

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REMARKS

The present invention relates to methods and systems for fabricating a field emission structure and device. Claims 1-35 are currently pending.


The Office Action has required restriction to one of the following inventions under 35 U.S.C. 121:

- I. Claims 1-28, drawn to a composition (and method of making said composition), classified in class 252, subclass 500.
- II. Claims 29-34, drawn to an X-ray source, classified in class 378, subclass 119+.
- III. Claim 35, drawn to a cathode ray tube, classified in class 313, subclass 364+.

The applicants hereby elect invention I, claims 1-28, drawn to a composition and method of making said composition.

If, in the opinion of the Examiner, a telephone conference would expedite the prosecution of the subject application, the Examiner is invited to call the undersigned attorney.

Respectfully submitted,

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